

FIG. 1A PRIOR ART

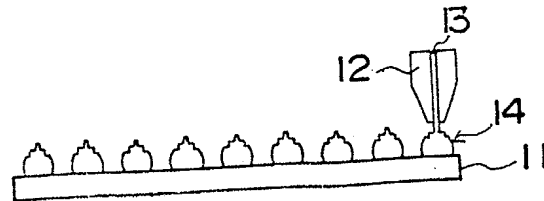


FIG. 1B PRIOR ART

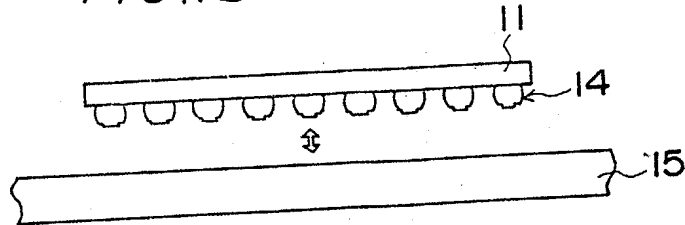


FIG. 1C PRIOR ART

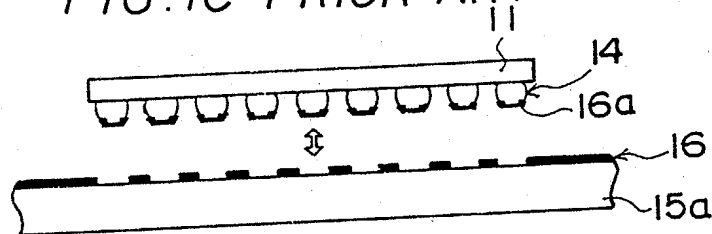


FIG. 1D PRIOR ART

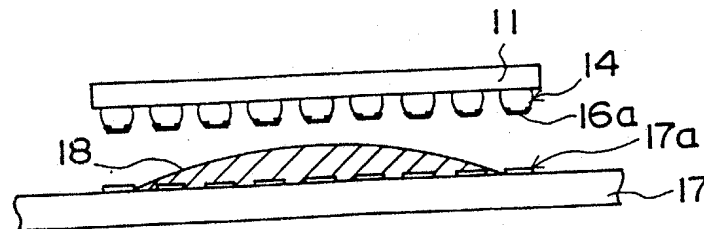


FIG. 1E PRIOR ART

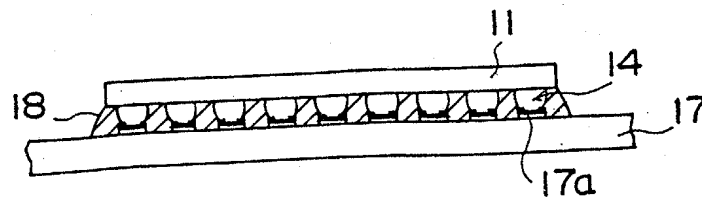
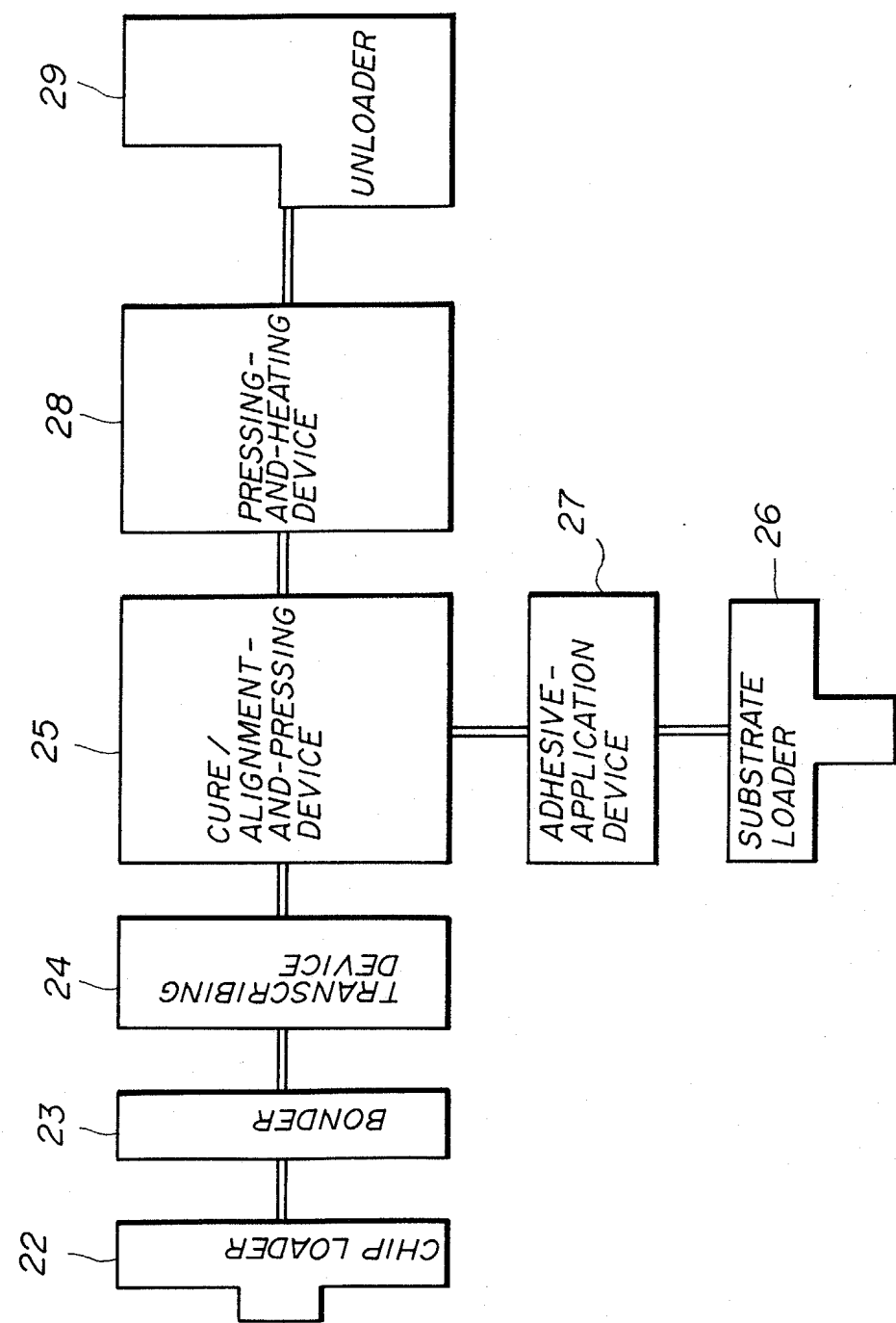
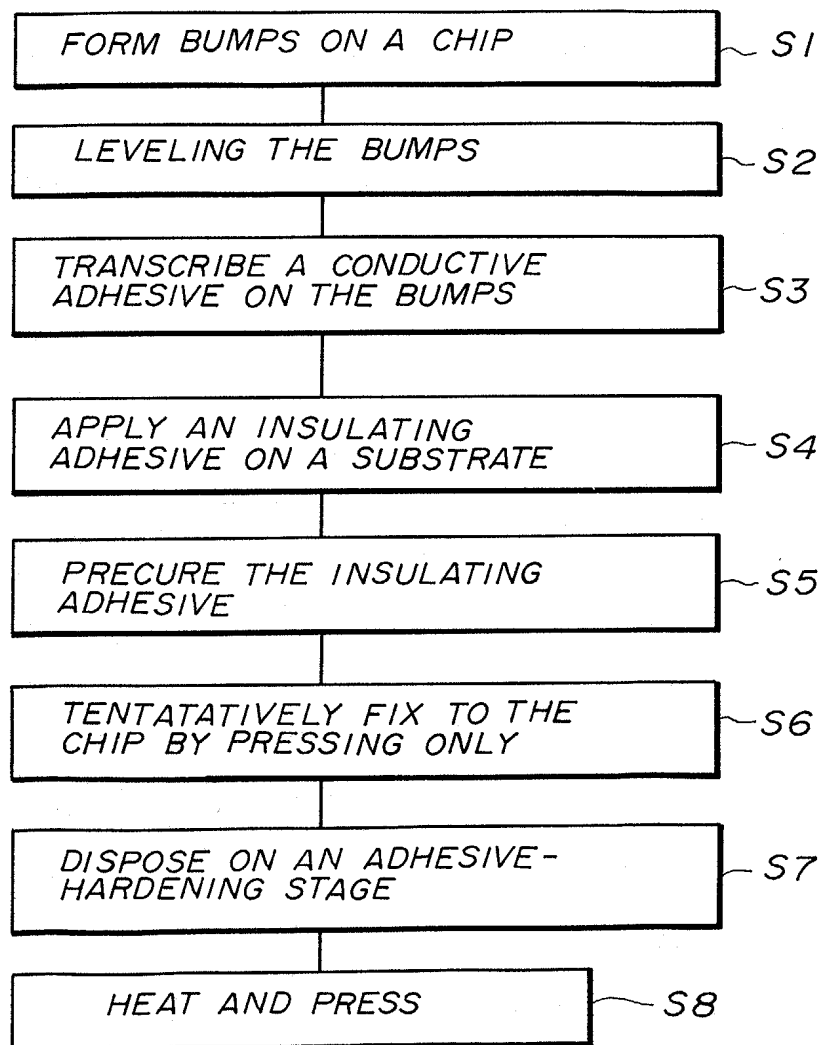


FIG. 2

21 FABRICATION SYSTEM



**FIG. 3**

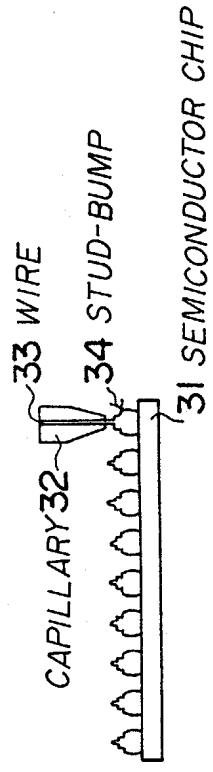


FIG. 4A

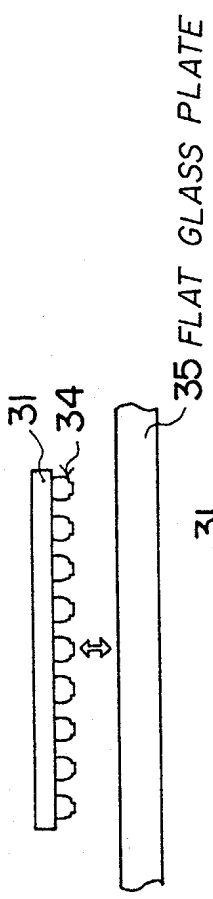


FIG. 4B

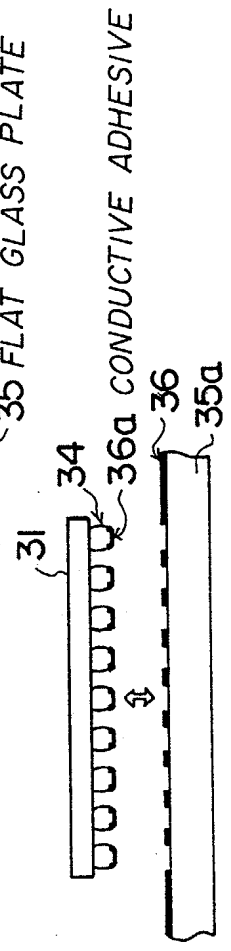


FIG. 4C

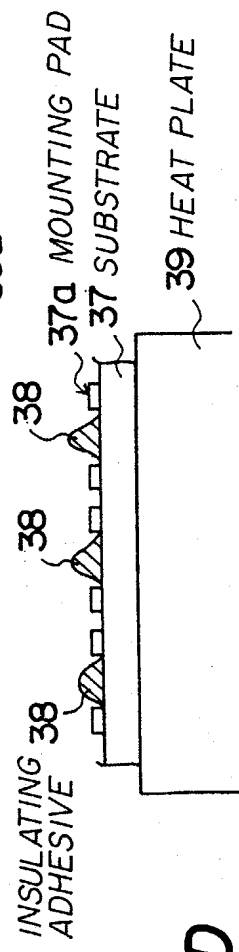


FIG. 4D

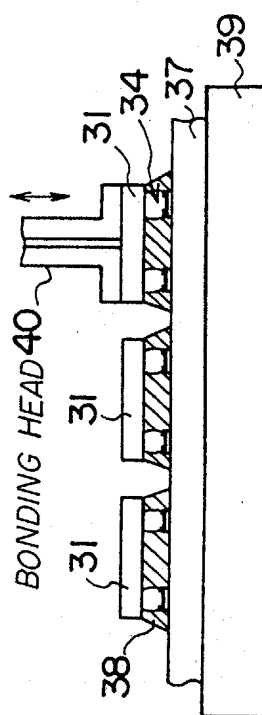


FIG. 4E

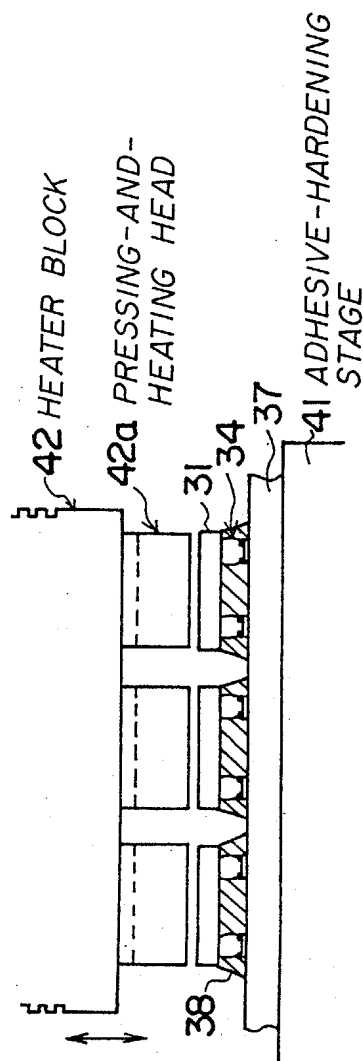


FIG. 4F

**FIG. 5**

51 SEMICONDUCTOR DEVICE

